

Scaling Properties of Charge Transport in Polycrystalline Graphene

Dinh Van Tuan¹, Jani Kotakoski², Thibaud Lowet^{1,3}, Frank Ortmann,¹ Jannik C. Meyer² and Stephan Roche,^{1,4}

¹CIN2 (ICN-CSIC) and Universitat Autònoma de Barcelona, Catalan Institute of Nanotechnology, Campus UAB, 08193 Bellaterra, Spain

²University of Vienna, Department of Physics, Boltzmannngasse 5, 1090 Wien, Austria

³Ecole Normale Supérieure de Lyon, 46, Allée d'Italie, 69007 Lyon, France

⁴ICREA, Institució Catalana de Recerca i Estudis Avançats, 08070 Barcelona, Spain

Contact: tuan.dinh@icn.cat

Abstract

Polycrystalline graphene is a patchwork of coalescing graphene grains of varying lattice orientations and size, resulting from the chemical vapor deposition (CVD)-growth at random nucleation sites on metallic substrates [1, 2, 3, 4, 5]. The morphology of polycrystalline graphene has become an important topic given its fundamental role in limiting the mobilities compared to mechanically exfoliated graphene monolayers [6]. The relationship between polycrystalline morphologies (grain sizes and grain boundary (GB) structures) and resulting physical properties is also a central aspect of the graphene roadmap in view of applications such as flexible electronics and high-frequency or spintronics devices [7]. Here we report new insights to the current understanding of charge transport in polycrystalline geometries. We first created realistic models of large CVD-grown graphene samples. Then, we used an efficient computational approach to compute charge mobilities within these systems as a function of the average grain size and the coalescence quality between the grains. Our results, which agree with recent experiments [8], reveal a remarkably simple scaling law for the mean free path and conductivity, correlated to atomic-scale charge density fluctuations (electron-hole puddles) along GBs. These findings establish quantitative foundations of transport features in polycrystalline graphene, thereby paving the way for improvements in graphene-based applications.

References

- [1] Li, X. S. *et al.*, *Science* **324**, 1312-1314 (2009).
- [2] Reina, A. *et al.*, *Nano Lett.* **9**, 30-35 (2009).
- [3] Bae, S. *et al.*, *Nature Nanotech.* **5**, 574-578 (2010).
- [4] Huang, P. Y. *et al.*, *Nature* **469**, 389-392 (2011).
- [5] Li, X. *et al.*, *J. Am. Chem. Soc.* **133**, 2816-2819 (2011).
- [6] Geim, A. K. & Novoselov, *Nature Mater.* **6**, 183-191 (2007).
- [7] Novoselov, K.S, Falko, V.I., Colombo, L., Gellert, P.R., Schwab, M.G., & Kim, K., *Nature* **192**, 490 (2012).
- [8] A.W. Tsen *et al.*, *Science* **336**, 1143 (2012).
- [9] T.V. Dinh *et al.*, Submitted to *Nano Lett.*

Figures

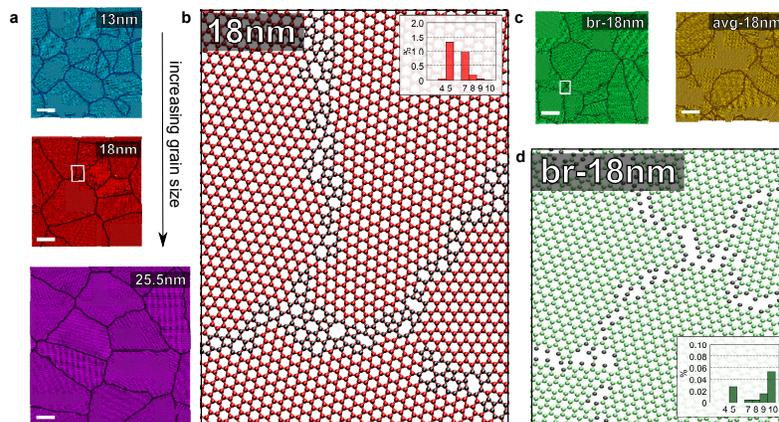


Figure 1: Polycrystalline graphene samples.

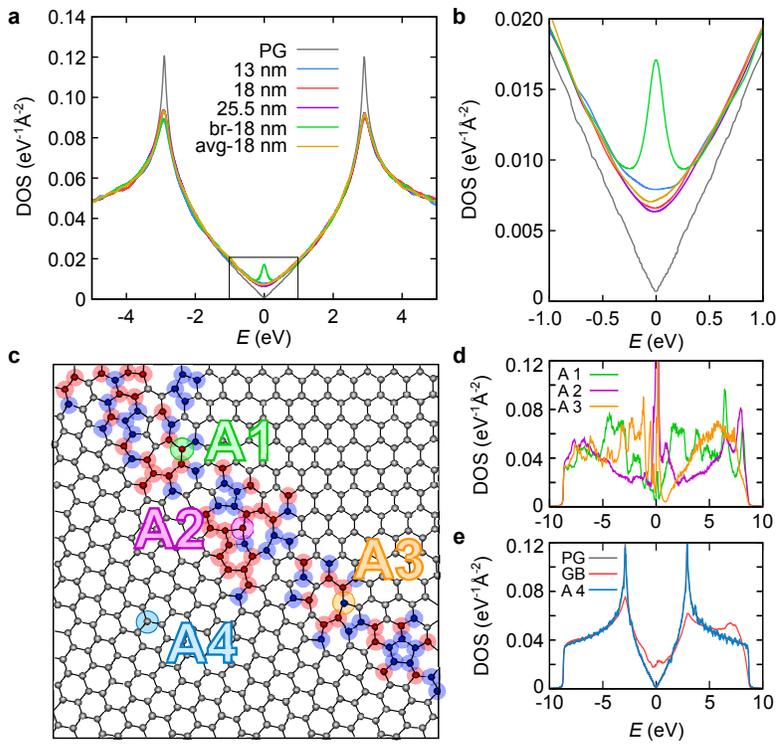


Figure 2: **Density of states (DOS)**. **a**. DOS for pristine graphene (PG) and the structures presented in Fig. 1. **b**. Higher magnification of the DOS close to the charge neutrality point ($E = 0$, area marked with a rectangle in panel **a**). **c**. Atomic structure of one of the boundaries in sample “18 nm”, showing the electron-hole puddles at GB sites that develop due to local variations in the charge density δ_i : local electron doping ($\delta_i < -1 \times 10^{-4}e/\text{atom}$) is shown in blue and local hole doping ($\delta_i > 1 \times 10^{-4}e/\text{atom}$) in red. **d**. Local DOS for atoms A1, A2 and A3 marked in panel **c**. **e**. Local DOS for atom A4 marked in panel **c** as compared to the average DOS for pristine graphene (PG) and average LDOS for all atoms at GBs in the same sample (GB).

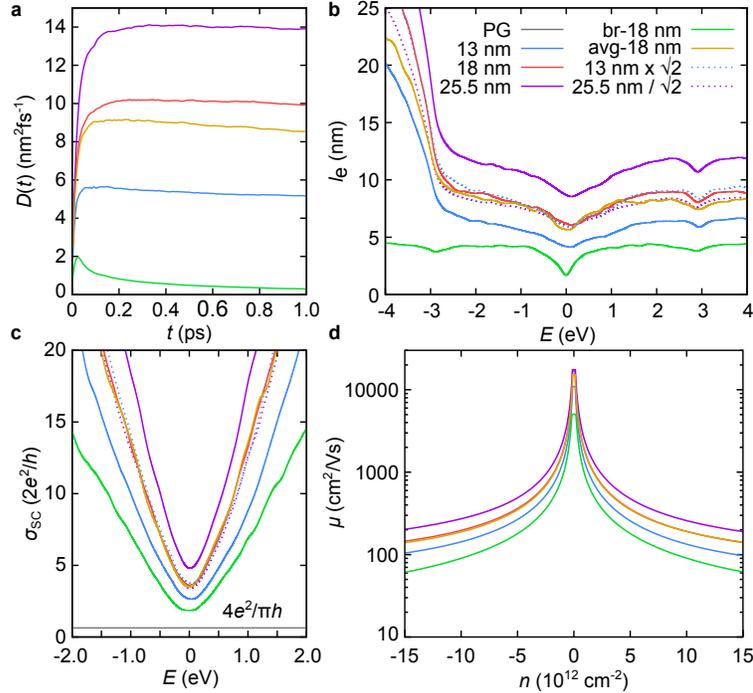


Figure 3: **Transport properties**. **a**. Diffusion coefficient ($D(t)$) for the samples presented in Fig. 1. **b**. Mean free path $\ell_e(E)$ for equivalent structures with scaled $\ell_e(E)$ for samples with $\langle d \rangle \approx 13$ nm and $\langle d \rangle \approx 25.5$ nm, showing the scaling law. **c**. Semi-classical conductivity ($\sigma_{sc}(E)$) for all samples and as scaled for the same cases as above. **d**. Charge mobility ($\mu(E) = \sigma_{sc}(E)/en(E)$) as a function of the carrier density $n(E)$ in each of the samples ($n(E) = 1/S \int_0^E \rho(E)dE$, S being a normalization factor).